In re application of

: Confirmation No. 9134

Shoriki NARITA et al.

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Group Art Unit 2625

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Examiner Sheela Chawan

METHOD AND APPARATUS FOR CORRECTING INCLINATION OF IC ON SEMICONDUCTOR WAFER

PATENT OFFICE FEE TRANSMITTAL FORM

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Sir:

Attached hereto is a check in the amount of \$720.00 to cover Patent Office fees relating to filing the following attached papers:

Petition for Extension of Time\$120.00

Additional Claims Fee Transmittal Letter

Independent\$600.00

A duplicate copy of this paper is being submitted for use in the Accounting Division, Office of Finance.

The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.

Respectfully submitted.

Shoriki NARIFA et a

W. Douglas Hahm

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[Check No. 7125]

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